



PATENT
Atty. Dkt. No. AMAT/3819/DSM/BCVD/JW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Suzuki, et al.

Serial No.: 10/004,489

Confirmation No.: 9428

Filed: October 23, 2001

**For: Method of Forming Film, Method
of Manufacturing Semiconductor
Device and Film Forming
Apparatus**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 2818

Examiner: Renee R. Berry

CERTIFICATE OF MAILING 37 CFR 1.8 I hereby certify that this correspondence is being deposited on August <u>27</u> , 2003 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450. <hr/> <u>8/27/03</u> <u>Kirt R. Shirey</u> Date Signature

RESPONSE TO OFFICE ACTION DATED JULY 9, 2003

In response to the Office Action dated July 9, 2003, having a shortened statutory period for response set to expire on October 9, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/3819/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. **Remarks/Arguments** begin on page 5 of this paper.